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Rec. No.: EV 096 406 875 US

On: FEBRUARY 7, 2003

By: *Linda E. Hastings*

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

ATTORNEY DOCKET NO. NECK 17.552 (100806 -17282)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
FEB 11 2003
TECHNOLOGY CENTER 2800

Inventor: Hiroshi TANABE

Serial No.: 09/614,286

Filed: July 12, 2000

Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS
AT DESIRED POSITIONS ON A SUBSTRATE**

Examiner: Timothy J. Sutton

Group Art Unit: 2813

Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action mailed on November 8, 2002, the period for responding thereto expiring after February 8, 2002, please amend the subject application as follows: